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AF/2800

Attorney Docket no: SEL 247

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
)
YAMAZAKI et al.)
)
Serial No.: 09/815,661)
)
Filed: March 23, 2001)
)
For: Method of Manufacturing A Light Emitting)
Device)
)
Examiner: S. Mulpuri)
)
Art Unit: 2812)

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RESPONSE B AFTER FINAL

Applicants have the following response to the Final Rejection of June 7, 2003

REMARKS

In the Final Rejection, the Examiner rejects Claims 1-26 under 35 USC §103 as being unpatentable over “admitted prior art”¹ in combination with Kim et al. (US 2002/0054268). This rejection is respectfully traversed.

In support of her rejection based on the “admitted prior art” and Kim, the Examiner contends that “[i]t would have been obvious to one of ordinary skill in the art to perform plasma treatment on

¹ The Examiner makes a reference to “Baldo et al.” on page 3 in support of her rejection. Applicants request a clarification as to what reference the Examiner is referring to as “Baldo et al.”